

INSTRUCTURED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Sun-Lee Hwang et al. : Group Art Unit: 2812

Application No. 10/805,225 : Examiner: TBA

Filed: March 22, 2004 :

For: METHOD OF ALIGNING A SEMICONDUCTOR SUBSTRATE WITH A

SEMICONDUCTOR ALIGNMENT APPARATUS

STATUS CHECK

U.S. Patent and Trademark Office Customer Service Window Randolph Building 401 Dulany Street Alexandria VA 22314

Sir:

Kindly immediately advise the undersigned of the status of the above-identified application.

Respectfully submitted,

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